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\*\* CONTINUING DATA ..... *ok*  
 This application is a CIP of 09/527,342 03/17/2000 PAT 6,528,751  
*m*

\*\* FOREIGN APPLICATIONS ..... *ok*  
*m*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
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Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 10	TOTAL CLAIMS 125	INDEPENDENT CLAIMS 12
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>Adrian</i>	Initials <i>n</i>		

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TITLE  
 Plasma reactor with overhead RF electrode tuned to the plasma with arcing suppression